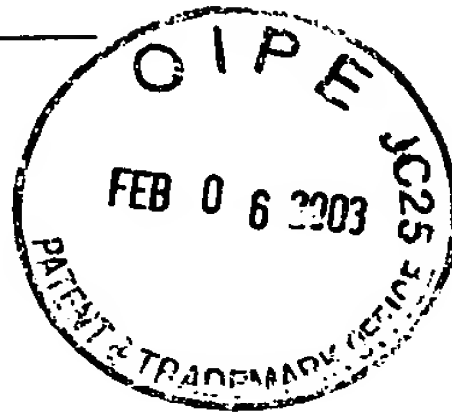


Inventor(s): OHMI et al.
 Appln. No.: 09 | 678,741
 Series Code ↑ | Serial No. ↑
 Filed: October 4, 2000
 Hon. Commissioner of Patents
 Washington, D.C. 20231

Group Art Unit 1763
 Examiner: Crowell, Anna M.
 Atty. Dkt. P 274025 | EL00009CDC
 M# | Client Ref
 Appln. Title: PLASMA PROCESSING APPARATUS



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 FEB 11 2003
 TC 1100 MAIL ROOM

Sir: **REPLY/AMENDMENT/LETTER**

Date: February 6, 2003

This is a reply/amendment/letter in the above-identified application and includes the herewith attachment of same date and subject which is incorporated hereinto by reference and the signature below is treated as the signature to the attachment in absence of a signature thereto.

FEE REQUIREMENTS FOR CLAIMS AS AMENDED

1. Small Entity claim A. <input checked="" type="checkbox"/> NOT made B. <input type="checkbox"/> Withdrawn C. <input type="checkbox"/> made herewith D. <input type="checkbox"/> made previously For B & C See Required Separate Paper (Pat-256)		Claims remaining after amendment	Highest number previously paid for	Present Extra	Large/Small Entity	Additional Fee	Fee Code Lg/Sm
2. Total Effective Claims		35	**minus 35	0	x \$18/\$9 =	+ \$0	103/203
3. Independent Claims		3	***minus 3	0	x \$84/\$42 =	+ \$0	102/202
4. If amendment enters proper multiple dependent claim(s) into this application for first time (leave blank if this is a reissue application) add					+ \$280/\$140 =	+ \$0	104/204
5. Original due Date: February 6, 2003		<input type="checkbox"/> NONE					
6. Petition is hereby made to extend the original due date to cover the date this response is filed for which the requisite fee is attached		(1 mo)	\$110/\$55 =	+ \$0			115/215
		(2 mos)	\$410/\$205 =				116/216
		(3 mos)	\$930/\$465 =				117/217
		(4 mos)	\$1,450/\$725 =				118/218
		(5 mos)	\$1,970/\$985 =				128/228
7. Enter any previous extension fee paid since above original due date and subtract					- \$0		
8.					Extension Fee	+ \$0	
9. If Terminal Disclaimer attached, add Rule 20(d) official fee					+ \$110/\$55	+ \$0	148/248
10. If IDS attached requires Official Fee under Rule 97 (c), add					+ \$180	+ \$0	126
or if Rule 97(d) Request add					+ \$180	+ \$0	126
11. After-Final Request Fee per rules 129(a) and 17(r)					+ \$750/370	+ \$0	146/246
12. No. of additional inventions for examination per Rule 129(b)					x \$750/375 ea	+ \$0	149/249
13. Request for Continued Examination (RCE)					+ \$750/375	+ \$0	1179/1279
14. Petition fee for						+ \$0	
15. TOTAL FEE =						\$0	
16. *If the entry in this space is less than entry in next space, the "Present Extra" result is "0".						PLEASE CHARGE OUR DEP. ACCT	
17. **If the "Highest number previously paid for" in this space is less than 20, write "20" in this space.							
18. ***If the "Highest number previously paid for" in this space is less than 3, write "3" in this space.							

Our Deposit Account No. 03-3975)
 (Our Order No. 40258 | 274025
 C# | M#

CHARGE STATEMENT: The Commissioner is hereby authorized to charge any fee specifically authorized hereafter, or any missing or insufficient fee(s) filed, or asserted to be filed, or which should have been filed herewith or concerning any paper filed hereafter, and which may be required under Rules 16-18 (missing or insufficiencies only) now or hereafter relative to this application and the resulting Official Document under Rule 20, or credit any overpayment, to our Accounting/Order Nos. shown above, for which purpose a duplicate copy of this sheet is attached.

This CHARGE STATEMENT does not authorize charge of the issue fee until/unless an issue fee transmittal sheet is filed.

Query: Is appeal deadline now? If so, file Notice of Appeals separately.

Pillsbury Winthrop LLP
 Intellectual Property Group
 By Atty: Glenn J. Perry
 Sig:
 P.O. Box 10500
 McLean, VA 22102
 Tel: (703) 905-2000
 Atty/Sec: GJP/EED
 Reg. No. 28,458
 Fax: (703) 905-2500
 Tel: (703) 905-2161

NOTE: File this cover sheet in duplicate with PTO receipt (PAT-103A) and attachments



REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 1763

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION OF

Confirmation No.: 9698

OHMI *et al.*

Group Art Unit: 1763

Appln. No.: 09/678,741

Examiner: CROWELL, ANNA M.

Filed: October 4, 2000

Title: PLASMA PROCESSING APPARATUS

#11BME
NW
2/12/03

February 6, 2003

RESPONSE AFTER FINAL UNDER 37 C.F.R. § 1.116

Hon. Commissioner of Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated November 6, 2002, please amend the above-identified application as follows:

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IN THE CLAIMS

Please enter the following amended claims:

1. (Twice Amended) A plasma processing apparatus for applying a process to a substrate to be processed, the plasma processing apparatus comprising:
- a chamber of which interior can be depressurized,
 - a gas supply system constructed and arranged to supply a gas to the chamber and an exhaust system configured and arranged to exhaust the gas supplied to the chamber and to depressurize the chamber;
 - a part of a wall constituting the chamber being a flat plate dielectric material plate formed of a material which passes a microwave therethrough substantially without a loss;

B
Sub